

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/567,070	VAN DUUREN, MICHAEL JOS	
Examiner		Art Unit		Page 1 of 1
Jason Lappas		2827		

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,778,443	08-2004	Shiga et al.	365/185.33
*	B	US-2001/0007541	07-2001	Hirakawa, Tsuyoshi	365/233
*	C	US-7,009,890	03-2006	Yamazoe et al.	365/189.01
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
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	V				
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	X				

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